

### **Inventor Information**

Inventor One Given Name:: Seiji  
Family Name:: FUJITSUKA  
Name Suffix::  
City of Residence:: Tokyo  
State or Prov. of Residence::  
Country of Residence::  
Inventor Two Given Name:: Masaichi  
Family Name:: MURAKAMI  
Name Suffix::  
City of Residence:: Tokyo  
State or Prov. of Residence::  
Country of Residence::  
Inventor Three Given Name:: Masaki  
Family Name:: KATO  
Name Suffix::  
City of Residence:: Tokyo  
State or Prov. of Residence::  
Country of Residence::  
Inventor Four Given Name:: Katsuya  
Family Name::  
Name Suffix:: MACHINO  
City of Residence:: Tokyo  
State or Prov. of Residence::  
Country of Residence::  
Inventor Five Given Name :: Manabu  
Family Name:: TOGUCHI  
Name Suffix::  
City of Residence:: Tokyo  
State or Prov. of Residence::  
Country of Residence:: Japan

### **Correspondence Information**

Correspondence Customer Number:: 25944  
Name Line One:: Oliff & Berridge PLC  
Address Line One:: P.O. Box 19928  
City:: Alexandria  
State or Province:: VA  
Postal or Zip Code:: 22320  
Telephone:: (703) 836-6400  
Fax:: (703) 836-2787  
Electronic Mail:: commcenter@oliff.com

### **Application Information**

Title Line One:: SCANNING EXPOSURE METHOD AND SYSTEM  
Total Drawing Sheets:: 28

Docket Number:: 108483

**Prior Foreign Applications**

Foreign Application One:: JP 2000-025661  
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Foreign Application Two:: JP 2000-026630  
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Priority Claimed:: yes

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